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U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ (If appropriate) Subclass Filing Date	
1.	DT	5,874,870	02/23/1999	Nishiyama et al.	333/202	
2.	DT	6,323,746 B1	11/27/2001	Prager et al.	333/219.1	
3.	Dī	6,255,917 B1	07/03/2001	Scott	29/527.2	
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5.	20	5,805,033	09/08/1998	Liang et al.	333/202	
6.	70	4,963,841	10/16/1990	Sparagna	333/202	
7.	DT	4,661,790	04/28/1987	Gannon et al.	333/234	
8.	DT	4,639,699	01/27/1987	Nishikawa et al.	333/202	
9.	Dr	4,028,652	06/07/1977	Wakino et al.	333/209	
10.	DF	4,725,798	02/16/1988	Igarashi	333/212	

FOREIGN PATENT DOCUMENTS							
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	No
1.	DT	53-076747 A	11/30/1976	Japan	NA	Partial	
2.	DT	63-110618	05/16/1988	Japan	HOIG 4/12	Partial	
3.	70	63-010603 A	01/23/1988	Japan	40177/10	Partial	
4.	27	63284902	11/22/1988	Japan	HOLF 7/16	Abstract	
5.	DT	63250201	10/18/1988	Japan	HOI A 7/16	Abstract	
6.	DT	0 859 423 A1	08/19/1998	Europe	HOIP 1/208		
7.	70	08065006 A	03/08/1996	Japan	HOLY VED	Abstract	
8.	74	2000-114809 A	04/21/2000	Japan	HOIP 1/205	Abstract	

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OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)					
Ref. Desig.	Examiner's Initials				
1.	דם	Farhat Abbas et al., "Ultra-high-Q resonators for low-noise, microwave signal generation using sapphire buffer layers and superconducting thin films"; Superconductor Science and Technology; Vol. 7, No. 7; July 1, 1994; pp. 495-501.			
2.	DT	Notice of Reasons of Rejection for Patent Application No. 2001-176674 and English Translation; Mailed September 24, 2003.			

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